## <Supplementary Information>

Supercapacitive Behavior Depending on Mesopore Size of Three-Dimensional Micro-, Meso- and Macroporous Silicon Carbide for Supercapacitors

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## (a) (b) 500 m(c) (1111) 252 m 50 m(c) (1111) (252 m) (1111) (252 m) (111) (220)(311)

## 1. TEM images and SAED pattern of 3MPSiC-C

Figure S1(a). Low-magnification FE-TEM image of 3MPSiC-C. (b,c). High- magnification FE-TEM image of 3MPSiC-C. (d). SAED pattern of 3MPSiC-C.

2. TEM images and SAED pattern of 3MPSiC-P



Figure S2(a). Low-magnification FE-TEM image of 3MPSiC-P. (b,c). High- magnification FE-TEM image of 3MPSiC-P. (d). SAED pattern of 3MPSiC-P.

## 3. XPS analysis of 3MPSiC materials

	Fitting of the Si 2p peak Binding energy [eV] (relative atomic percentage [%])			
	Si-C	SiOC <sub>3</sub>	SiO <sub>2</sub> C <sub>2</sub>	SiO <sub>3</sub> C
3MPSiC-C	99.5	100.42	101.33	102.12
	(70.5)	(14.12)	(9.09)	(6.29)
3MPSiC-B	99.51	100.44	101.34	102.15
	(71.21)	(14.61)	(8.47)	(5.71)
3MPSiC-P	99.51	100.46	101.37	102.17
	(71.18)	(14.14)	(8.78)	(5.9)

Table S1. The Si 2p peak position and the relative atomic percentages of various peaks in 3MPSiC

	Fitting of the C 1s peak Binding energy [eV] (relative atomic percentage [%])				
_	Si-C	SiO <sub>x</sub> C <sub>y</sub>	C-C		
3MPSiC-C	282.81	283.74	284.6		
	(60.6)	(25.22)	(14.18)		
3MPSiC-B	282.81	283.79	284.62		
	(60.03)	(24.83)	(15.14)		
3MPSiC-P	282.81	283.86	284.59		
	(61.38)	(24.68)	(13.94)		

Table S2. The C 1s peak position and the relative atomic percentages of various peaks in 3MPSiC

4. Deconvoluted Si 2p, C 1s and O 1s XPS spectra of 3MPSiC-C



Figure S3(a). XPS Si 2p spectra of 3MPSiC-C.



Figure S3(b). XPS C 1s spectra of 3MPSiC-C.



Figure S3(c). XPS O 1s spectra of 3MPSiC-C.

5. Deconvoluted Si 2p, C 1s and O 1s XPS spectra of 3MPSiC-P



Figure S4(a). XPS Si 2p spectra of 3MPSiC-P.



Figure S4(b). XPS C 1s spectra of 3MPSiC-P.



Figure S4(c). XPS O 1s spectra of 3MPSiC-P.